

Notice of References Cited	Application/Control No. 10/615,328	Applicant(s)/Patent Under Reexamination MCNEIL ET AL.	
	Examiner John E Chapman	Art Unit 2856	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,159,761	12-2000	Okada, Kazuhiro	73/514.32
	C	US-6,629,461	10-2003	Behin et al.	73/514.16
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Arjun Selvakumar et al., "A High-Sensitivity Z-Axis Capacitive Silicon Microaccelerometer with a Torsional Suspension," Journal of Micromechanical Systems, Vol. 7, No. 2, June 1998, pp. 192-200.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.